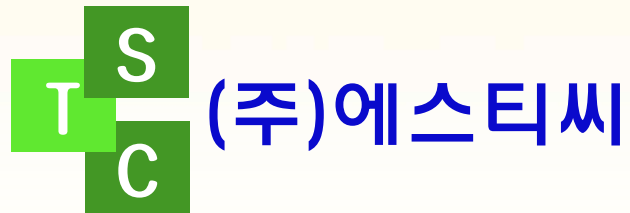


Plasma Wet Scrubber

소개자료



<http://stc-tech.co.kr>

■ Plasma Scrubber 원리

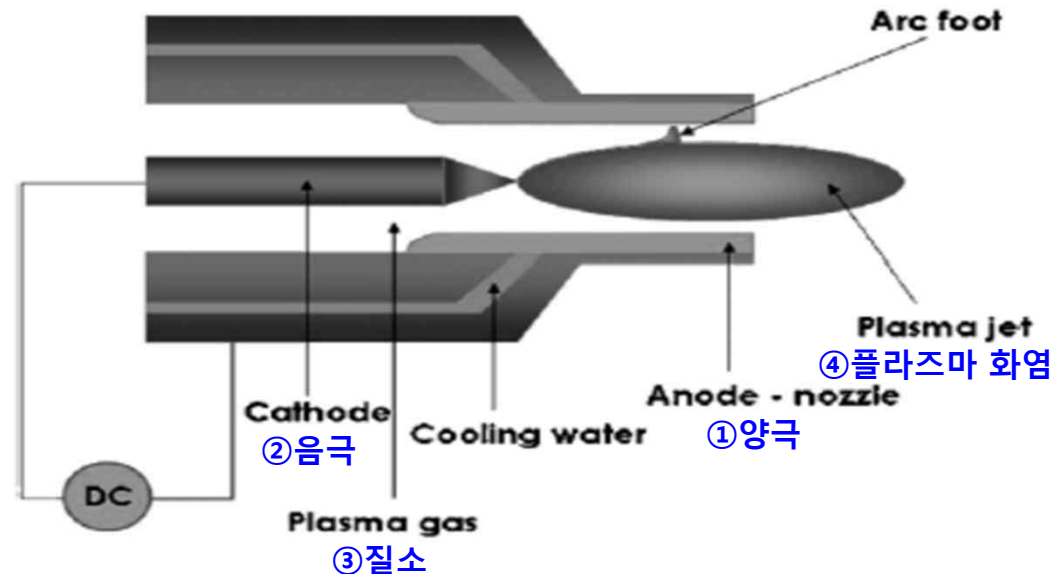
반도체 제조공정에 사용하는 Gas 중 **PFC Gas**(CF₄, C₂F₆, C₃F₈, SF₆, NF₃, CH₂F₂ 등)의 처리를 위해서는 고온의 열분해가 필요합니다.

열분해 온도는 약 1500°C입니다.

기존 Heater식 또는 연소식 Scrubber는 위의 온도까지 고온으로 운전하기에 무리가 있어 개발된 방식이 Plasma Scrubber 입니다.

Plasma 생성 방법에는 Micro-Wave, RF, Arc 등이 있는데 당사는 Arc-Plasma 발생장치를 사용합니다.

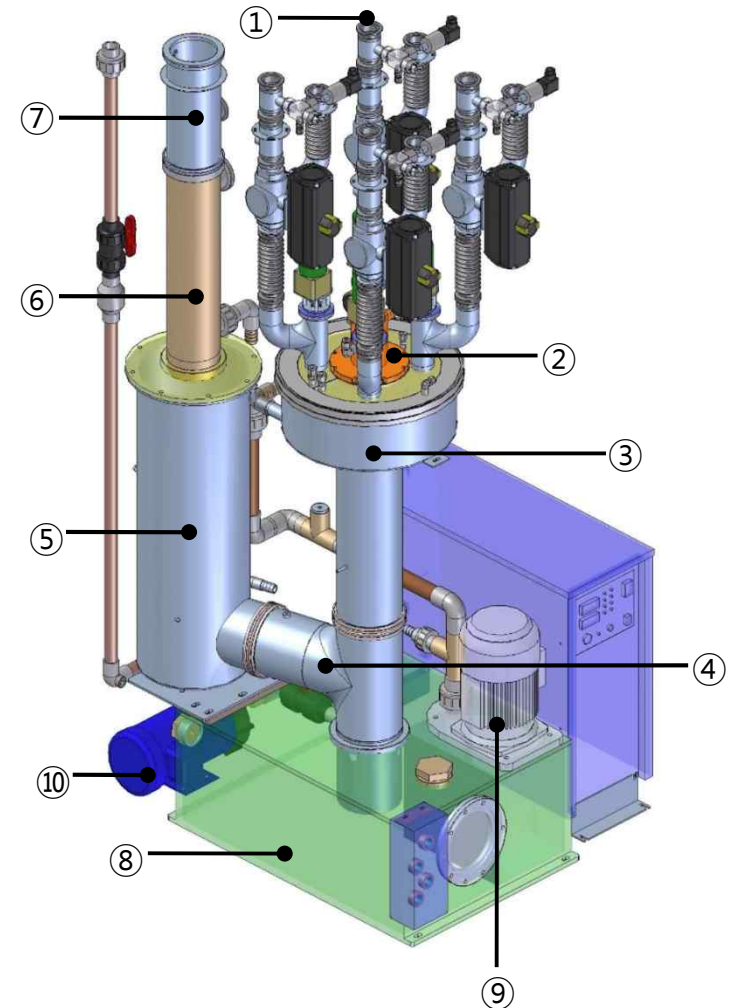
Arc-Plasma는 직류 전원장치에서 공급되는 전원을 Plasma Torch의 양극(①)과 음극(②)에 연결되고 두 극 사이에 질소(③)를 통과시키면서 전원을 공급하면 1500°C 이상의 고온 Plasma 화염(④)이 분출됩니다.



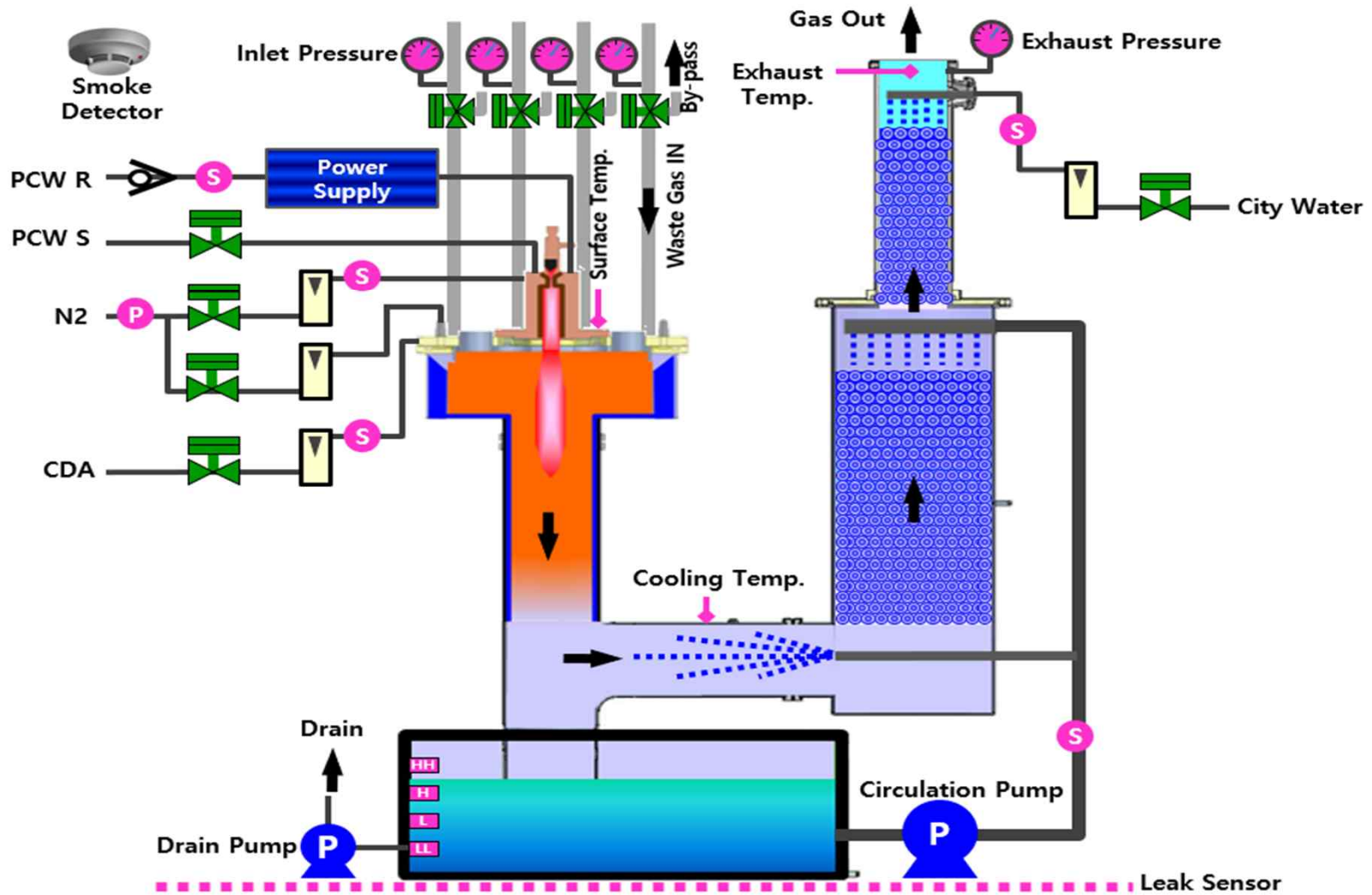
■ 일반사양 및 구조

일반 사양		
Type	Plasma & Wet	
Capacity	500slm(included scrubber utility)	
	Inlet Capacity	300slm
Dimension(mm)	850(W) × 1000(D) × 2000(H)	
Weight	600kg	

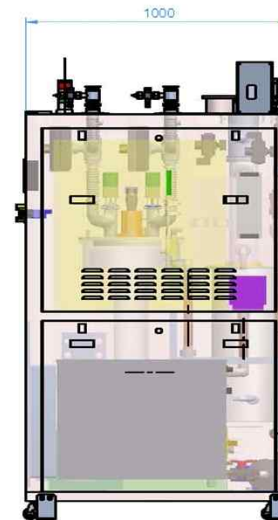
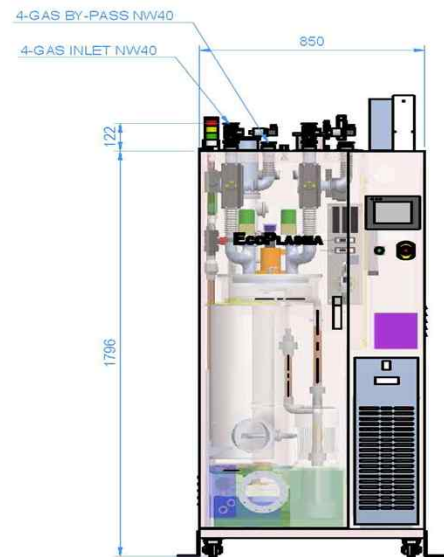
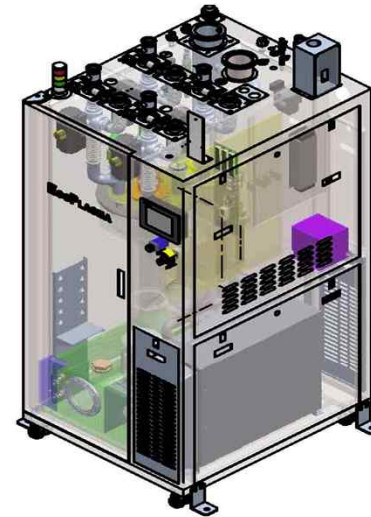
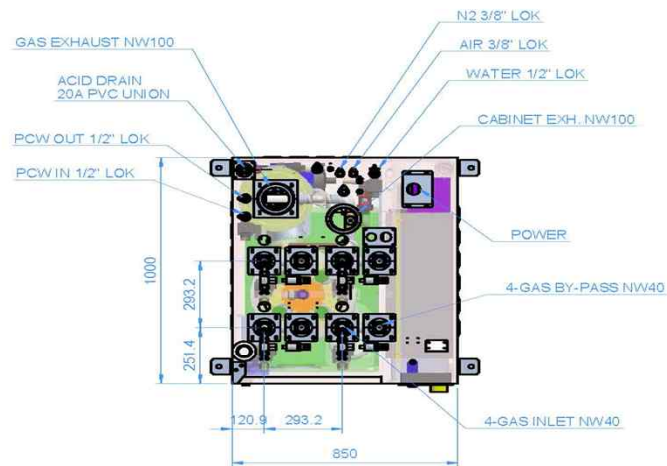
Component		Function
1	Waste Gas Inlet	Waste Gas Inflow
2	Plasma Torch	Plasma Generator
3	Reactor	Gas Mixing & Treat
4	Cooling Chamber	Gas Cooling
5	1 st Wet Tower	Treat waste gases & powder
6	2 nd Wet Tower	Gas Final Washing
7	Exhaust	Gas Exit
8	Circulation Tank	Circulating Water Storage Tank
9	Circulation Pump	Water Circulation
10	Drain Pump	Overflow Water Drain



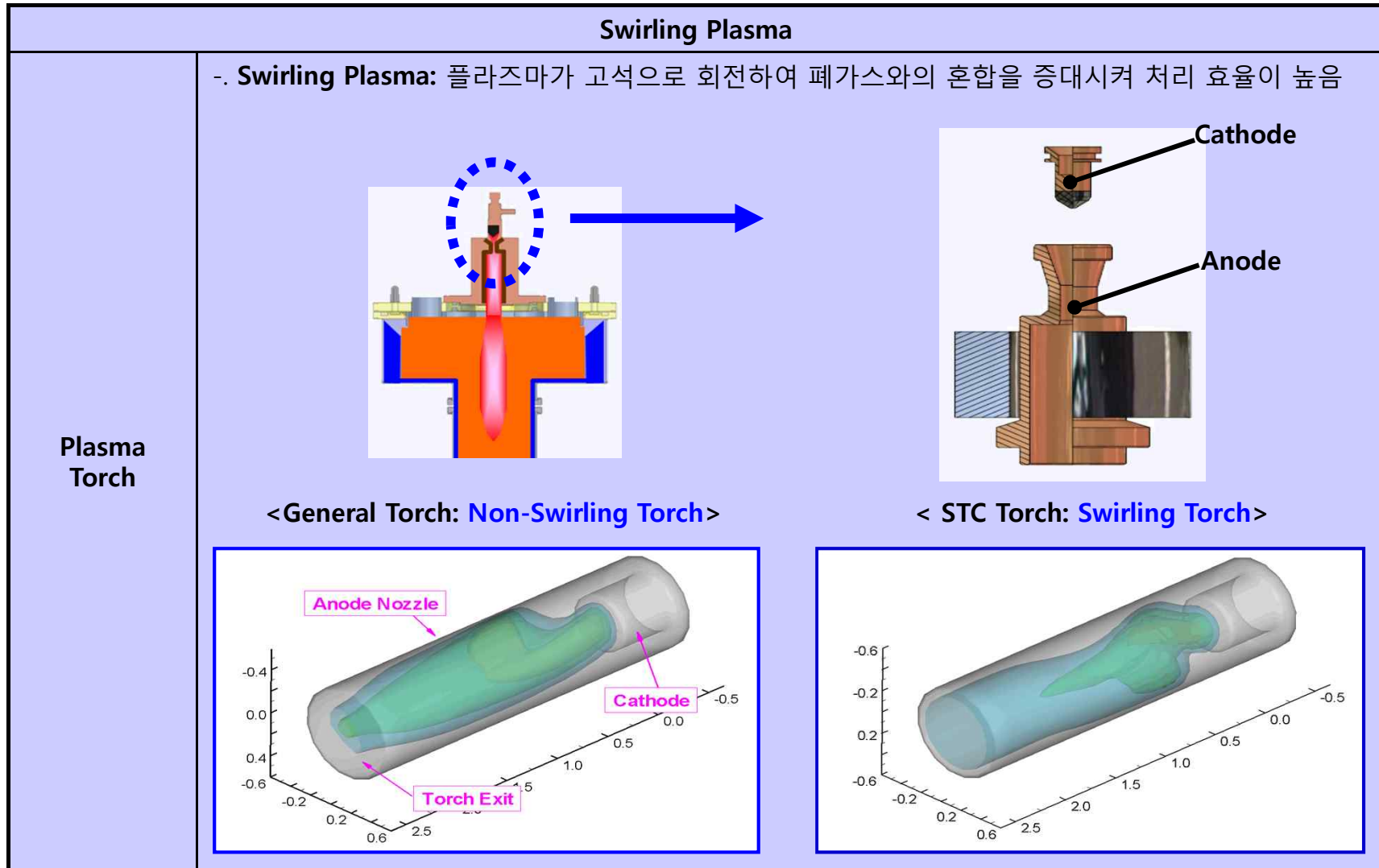
■ Scrubber 공정도



■ Scrubber External Dimension



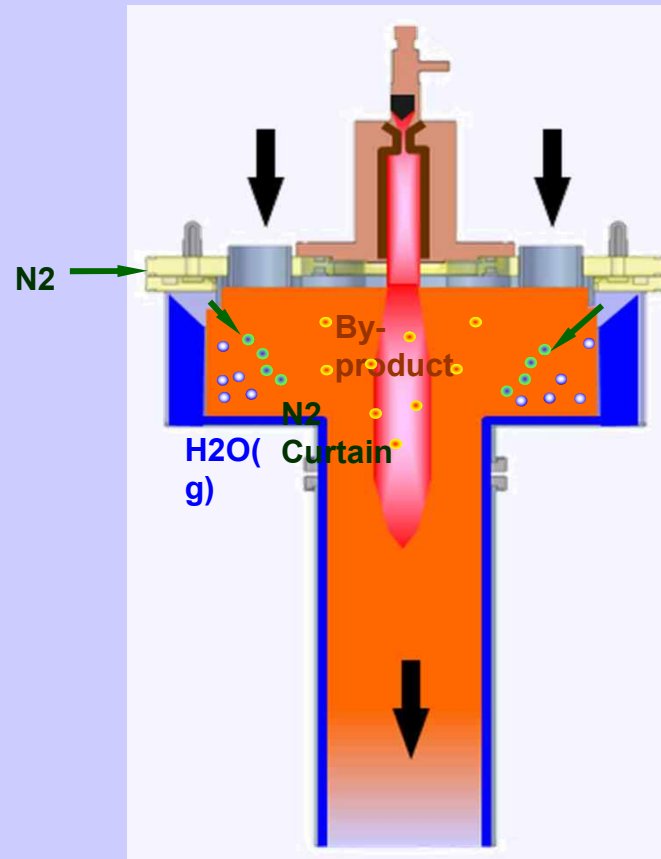
특징



N2 Curtain과 Swirling Water 반응기

Reactor

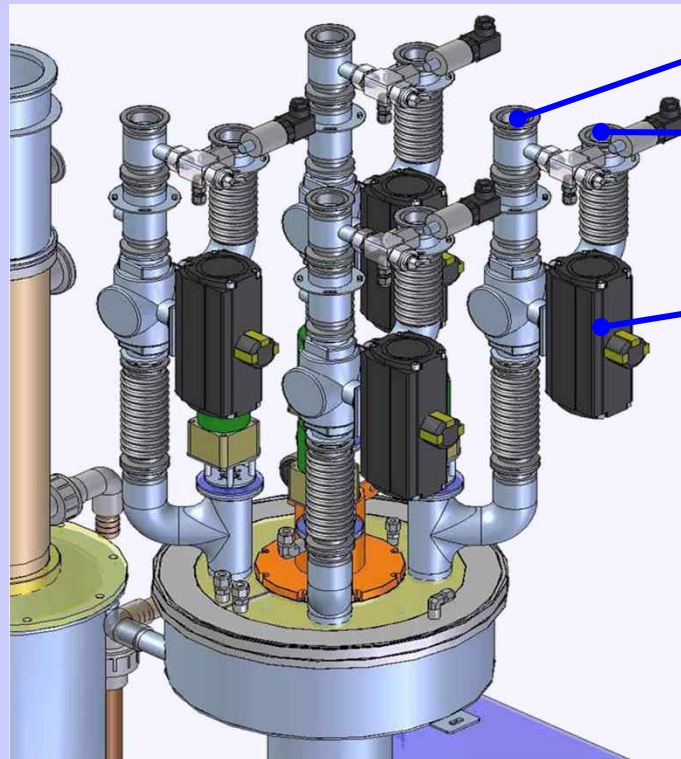
- **N2 Curtain** : Gas Inlet부에 N2 Curtain을 형성하여 Powder 적체에 강한 구조
- **Swirl Cooling Water** : Reactor 내벽에 물이 흘러내리는 구조로서 Powder 적체에 강함



3-Way Valve 적용

- 3Way Valve : 비상시 By-pass됨
- Inlet Pressure Sensor : 4개의 Inlet에 각각 설치됨

Waste Gas Inlet



Waste Gas Inlet 4Ports

By-pass 4Ports

3 Way Valve 4Sets

■ Gas 반응 Mechanism

Gas	Reaction	DRE Efficiency
SiH4	$\text{SiH}_4 + 2\text{O}_2 \rightarrow \text{SiO}_2 + 2\text{H}_2\text{O}$	$\geq 99\%$
H2	$2\text{H}_2 + \text{O}_2 \rightarrow 2\text{H}_2\text{O}$	$\geq 99\%$
PH3	$2\text{PH}_3 + 3\text{O}_2 \rightarrow \text{P}_2\text{O}_5 + 3\text{H}_2\text{O}$	$\geq 99\%$
DCS(SiH2Cl2)	$\text{SiH}_2\text{Cl}_2 + 3/2\text{O}_2 \rightarrow \text{SiO}_2 + \text{H}_2\text{O} + \text{Cl}_2$	$\geq 99\%$
TEOS	$(\text{C}_2\text{H}_5\text{O})_4\text{Si} + 12\text{O}_2 \rightarrow 8\text{CO}_2 + \text{SiO}_2 + 10\text{H}_2\text{O}$	$\geq 99\%$
WF6	$2\text{WF}_6 + 3/2\text{O}_2 \rightarrow \text{W}_2\text{O}_3 + 6\text{F}_2$	$\geq 99\%$
B2H6	$\text{B}_2\text{H}_6 + 3\text{O}_2 \rightarrow \text{B}_2\text{O}_3 + 3\text{H}_2\text{O}$	$\geq 99\%$
NF3	$2\text{NF}_3 \rightarrow \text{N}_2 + 3\text{F}_2$	$\geq 99\%$
SF6	$\text{SF}_6 + \text{O}_2 \rightarrow \text{SO}_2 + 3\text{F}_2$	$\geq 98\%$
CF4	$\text{CF}_4 + \text{O}_2 \rightarrow \text{CO}_2 + 2\text{F}_2$	$\geq 95\%$
NH3	Water Soluble	$\geq 99\%$
HF	Water Soluble	$\geq 99\%$
ClF3	Water Soluble	$\geq 99\%$

■ Safety 설계 및 사양

Component	Safety Issue	Safety Design
Torch	Over-heat	- . PCW Cooling System: PCW Flow Sensor ▶ Plasma Power Interlock
Power Supply	Over-heat	- . PCW Cooling System: PCW Flow Sensor ▶ Plasma Power Interlock - . Power 장치 내부에 Thermister가 설치됨 ▶ Power 내부 온도가 85°C 이상이 되면 자동 Trip됨
Reactor	Over-heat	- . 온도가 센서가 Reactor 표면에 설치됨 ▶ Plasma Power Interlock(at 250°C or more)
Exhaust	Over-heat	- . 온도가 센서가 Exhaust 내부에 설치됨 ▶ Plasma Power Interlock(at 50°C or more) - . Supply Water Flow Sensor ▶ Plasma Power Interlock
Wet Chamber	Over-heat	- . Circulation Water Flow Sensor ▶ Plasma Power Interlock
Electrical Parts	Fire	- . 모든 전기부품은 SEMI-S2 규격품을 사용함
Breaker	Over-current (Fire)	- . 과전류 차단기가 설치됨

Utility 사양

Utility	Specification	Maximum Requirement	Average Consumption	Connection	etc
Power	A/C 220V/380V, 50/60Hz 3 Phase, 100A/50A	20KW	10KW	16mm ² -4Wires	Include Neutral Wire
CDA	4 ~ 7kg/cm ²	100 SLM	40 SLM	3/8" Tube	Burning Air Sleeve Air
N2	4 ~ 7kg/cm ²	100 SLM	50 SLM	3/8" Tube	
PCW	3 ~ 5kg/cm ²	15L/min	10L/min	3/4" Tube	
City Water	3 ~ 5kg/cm ²	8L/min	6L/min	3/4" Tube	
Drain	Acid Drain	8L/min	6L/min	20A PVC Pipe	Power Drain
Gas Exhaust	-50mmH ₂ O ~ -100mmH ₂ O	2m ³ /min	1m ³ /min	NW100 Flange	
Cabinet Exhaust	-20mmH ₂ O ~ -50mmH ₂ O	2m ³ /min	1m ³ /min	NW100 Flange	

감사합니다